Application/Control No. Applicant(s)/Patent Under Reexamination 10/081,398 HAIHONG, ZHENG Notice of References Cited Examiner Art Unit Page 1 of 1 Clemence Han 2668 **U.S. PATENT DOCUMENTS Document Number** Date Classification Name Country Code-Number-Kind Code MM-YYYY 370/252 * 12-2003 Goguen et al. US-6,665,273 Α 370/395.2 * 06-2002 Reeves et al. US-2002/0080794 В

Nomura, Yuji

Kuehnel, Thomas

Wakayama et al.

Mark et al.

08-2002

06-2003

10-2004

02-2006

US-2002/0103924

US-2003/0118019

US-2004/0202148

US-2006/0034292

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G

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US-

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US-US-

US-

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	FOREIGN PATENT DOCUMENTS					
*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	D					
	R					
	s					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
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	w						
	x						

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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370/392

370/352

370/395.5